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In this excellent text Professor Wei Gao from Tohoku University describes the essential aspects of a relatively new discipline: precision nanometrology. This forms a new field of dimensional metrology that is defined as the science of dimensional measurement with nanometric accuracy over a broad measurement range from micrometres to metres.

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Precision Nanometrology describes the new field of precision nanometrology, which plays an important part in nanoscale manufacturing of semiconductors, optical elements, precision parts and similar items. It pays particular attention to the measurement of surface forms of precision workpieces and to stage motions of precision machines.

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For precision length measurements in the range of nanometers up to several meters, interferometric methods are used in which the length to be measured is compared with one or more known light wavelengths.

Precision metrology - Technische Universität Ilmenau

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Starting from the fundamentals of precision measurement, the author progresses into different measurement and characterization techniques. The focus on nanometrology in engineering contexts makes this book an essential guide for the emerging nanomanufacturing / nanofabrication sector, where measurement and standardization requirements are ...

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Precision Nanometrology describes the new field of precision nanometrology, which plays an important part in nanoscale manufacturing of semiconductors, optical elements, precision parts and similar items. It pays particular attention to the measurement of surface forms of precision workpieces and to stage motions of precision machines. The first half of the book is dedicated to the description of optical sensors for the measurement of angle and displacement, which are fundamental quantities for precision nanometrology. The second half presents a number of scanning-type measuring systems for surface forms and stage motions. The systems discussed include: • error separation algorithms and systems for measurement of straightness and roundness, • the measurement of micro-aspherics, • systems based on scanning probe microscopy, and • scanning image-sensor systems. Precision Nanometrology presents the fundamental and practical technologies of precision nanometrology with a helpful selection of algorithms, instruments and experimental data. It will be beneficial for researchers, engineers and postgraduate students involved in precision engineering, nanotechnology and manufacturing.

Surface Metrology for Micro- and
Nanofabrication presents state-of-the-art

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measurement technologies for surface metrology in fabrication of micro- and nanodevices or components. This includes the newest general-purpose scanning probe microscopes, and both contact and non-contact surface profilers. In addition, the book outlines characterization and calibration techniques, as well as in-situ, on-machine, and in-process measurements for micro- and nanofabrication. Provides materials scientists and engineers with an informed overview of the state-of-the-art in surface metrology Helps readers select and design the optimized surface metrology systems and carry out proper surface metrology practices in the fabrication of micro/nano-devices and components Assesses the best techniques for repairing micro-defects

This collection represents successful invited submissions from the papers presented at the 8th Annual Conference of Energy Economics and Management held in Beijing, China, 22–24 September 2017. With over 500 participants, the conference was co-hosted by the Management Science Department of National Natural Science Foundation of China, the Chinese Society of Energy Economics and Management, and Renmin University of China on the subject area of “Energy Transition of China: Opportunities and Challenges”. The major strategies to transform the energy system of China to a sustainable model include energy/economic structure adjustment,

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resource conservation, and technology innovation. Accordingly, the conference and its associated publications encourage research to address the major issues faced in supporting the energy transition of China. Papers published in this collection cover the broad spectrum of energy economics issues, including building energy efficiency, industrial energy demand, public policies to promote new energy technologies, power system control technology, emission reduction policies in energy-intensive industries, emission measurements of cities, energy price movement, and the impact of new energy vehicle.

This book contains reviews of recent experimental and theoretical results related to nanomaterials. It focuses on novel functional materials and nanostructures in combination with silicon on insulator (SOI) devices, as well as on the physics of new devices and sensors, nanostructured materials and nano scaled device characterization. Special attention is paid to fabrication and properties of modern low-power, high-performance, miniaturized, portable sensors in a wide range of applications such as telecommunications, radiation control, biomedical instrumentation and chemical analysis. In this book, new approaches exploiting nanotechnologies (such as UTBB FD SOI, Fin FETs, nanowires, graphene or carbon nanotubes on dielectric) to pave a way

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between “More Moore” and “More than Moore” are considered, in order to create different kinds of sensors and devices which will consume less electrical power, be more portable and totally compatible with modern microelectronics products.

Handbook of Manufacturing provides a comprehensive overview of fundamental knowledge on manufacturing, covering various processes, manufacturing-related metrology and quality assessment and control, and manufacturing systems. Many modern processes such as additive manufacturing, micro- and nano-manufacturing, and biomedical manufacturing are also covered in this handbook. The handbook will help prepare readers for future exploration of manufacturing research as well as practical engineering applications.

Working at the nano-scale demands an understanding of the high-precision measurement techniques that make nanotechnology and advanced manufacturing possible. Richard Leach introduces these techniques to a broad audience of engineers and scientists involved in nanotechnology and manufacturing applications and research. He also provides a routemap and toolkit for metrologists engaging with the rigor of measurement and data analysis at the nano-scale. Starting from the fundamentals of precision measurement, the author progresses

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into different measurement and characterization techniques. The focus on nanometrology in engineering contexts makes this book an essential guide for the emerging nanomanufacturing / nanofabrication sector, where measurement and standardization requirements are paramount both in product specification and quality assurance. This book provides engineers and scientists with the methods and understanding needed to design and produce high-performance, long-lived products while ensuring that compliance and public health requirements are met. Updated to cover new and emerging technologies, and recent developments in standards and regulatory frameworks, this second edition includes many new sections, e.g. new technologies in scanning probe and e-beam microscopy, recent developments in interferometry and advances in co-ordinate metrology. Demystifies nanometrology for a wide audience of engineers, scientists, and students involved in nanotech and advanced manufacturing applications and research. Introduces metrologists to the specific techniques and equipment involved in measuring at the nano-scale or to nano-scale uncertainty. Fully updated to cover the latest technological developments, standards, and regulations.

New, significant scientific discoveries in laser and photonic technologies, systems perspectives, and integrated design

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approaches can improve even further the impact in critical areas of challenge. Yet this knowledge is dispersed across several disciplines and research arenas. *Laser and Photonic Systems: Design and Integration* brings together a multidisciplinary group of experts to increase understanding of the ways in which systems perspectives may influence laser and photonic innovations and application integration. By bringing together chapters from leading scientists and technologists, industrial and systems engineers, and managers, the book stimulates new thinking that would bring a systems, network, and system-of-systems perspective to bear on laser and photonic systems applications. The chapters challenge you to explore opportunities for revolutionary and broader advancements. The authors emphasize the identification of emerging research and application frontiers where there are promising contributions to lasers, optics, and photonics applications in fields such as manufacturing, healthcare, security, and communications. The book contains insights from leading researchers, inventors, implementers, and innovators. It explains a variety of techniques, models, and technologies proven to work with laser and photonic systems, their development, design, and integration. Such systems are of growing interest to many organizations, given their promise and potential solutions of grand societal challenges. Lastly, the book helps

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you leverage the knowledge into exciting new
frontiers of successful solutions.

We face many challenges in the 21st century, such as sustainably meeting the world's growing demand for energy and consumer goods. I believe that new developments in science and technology will help solve many of these problems. Nanofabrication is one of the keys to the development of novel materials, devices and systems. Precise control of nanomaterials, nanostructures, nanodevices and their performances is essential for future innovations in technology. The book "Nanofabrication" provides the latest research developments in nanofabrication of organic and inorganic materials, biomaterials and hybrid materials. I hope that "Nanofabrication" will contribute to creating a brighter future for the next generation.

Volume is indexed by Thomson Reuters BCI (WoS). Measurement, rigorously defined as [ascertaining the size, amount or degree of a measurand by instrumental comparison with a standard unit or by indirect calculation based upon theory], is what makes science and technology different to imagination. Measurement is essential in industry, commerce and daily life. In the manufacturing industry in particular, measurement and instrumentation technology play increasingly

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Important roles not only in the traditional field of manufacturing but also in the new fields of micro/nano technology and bioengineering. This book presents recent advances in the use of measurement and instrumentation in the manufacturing industry. A wide range of topics are covered including: micro/nano-metrology, precision measurements, online and in-process measurements, surface metrology, optical metrology and image processing, bio-measurement, sensor technology, intelligent measurement and instrumentation, uncertainty, traceability and calibration and signal-processing algorithms.

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